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Chemisorption of Anionic Species from the Electrolyte Alters the Surface Electronic Structure and Composition of Photocharged BiVO₄

Nienke J. Firet, Anirudh Venugopal, Marijn A. Blommaert, Chiara Cavallari, Christoph J. Sahle, Alessandro Longo, and Wilson A. Smith

ABSTRACT: Photocharging has recently been demonstrated as a powerful method to improve the photoelectrochemical water splitting performance of different metal oxide photoanodes, including BiVO₄. In this work, we use ambient-pressure X-ray Raman scattering (XRS) spectroscopy to study the surface electronic structure of photocharged BiVO₄. The O K edge spectrum was simulated using the finite difference method near-edge structure program package, which revealed a change in electron confinement and occupancy in the conduction band. These insights, combined with ultraviolet-visible spectroscopy and X-ray photoelectron spectroscopy analyses, reveal that a surface layer formed during photocharging creates a heterojunction with BiVO₄, leading to favorable band bending and strongly reduced surface recombination. The XRS images presented in this work exhibit good agreement with soft X-ray absorption near-edge structure spectra from the literature, demonstrating that XRS is a powerful tool to study the electronic and structural properties of light elements in semiconductors. Our findings provide direct evidence of the electronic modification of a metal oxide photoanode surface as a result of the adsorption of electrolyte anionic species under operating conditions. This work highlights that the surface adsorption of these electrolyte anionic species is likely present in most studies on metal oxide photoanodes and has serious implications for the photoelectrochemical performance analysis and fundamental understanding of these materials.

INTRODUCTION

Bismuth vanadate (BiVO₄) is an extensively investigated n-type metal oxide semiconductor that has shown promising properties for photoelectrochemical (PEC) water splitting. It has generated the highest photocurrent for a metal oxide photoanode to date, and the band gap of 2.4 eV could potentially be suitable to make BiVO₄ a good top absorber in tandem PEC devices with a low band gap bottom absorber. In addition, the optoelectronic properties of BiVO₄ are easily modified: the material can accommodate a large number of defects and dopants, enabling a high degree of material engineering making BiVO₄ a suitable model photoanode. Many improvements in the PEC performance of BiVO₄ have used the addition of dopants to improve electron conductivity or the addition of co-catalysts to improve the kinetics of the oxygen evolution reaction (OER).

Interestingly, recent work by Zachäus et al. showed that surface recombination is one of the major performance-limiting factors for BiVO₄. In fact, the presence of a cobalt phosphate (CoPi) catalyst on the surface of BiVO₄ suppresses surface recombination by aiding the transfer of holes from the semiconductor valence band (VB) to the OER intermediates. While CoPi effectively suppresses surface recombination, it also introduces parasitic light absorption, which is unwanted in a practical device. Recently, the photocharging (PC) technique has been introduced on BiVO₄ photoanodes, which drastically reduced the onset potential for OER and increased the photocurrent density and fill factor of PC-BiVO₄ compared to untreated BiVO₄. This treatment was performed by exposing BiVO₄ photoanodes to prolonged exposure of AM1.5 illumination under open-circuit conditions in a neutral electrolyte. After extensive material character-
ization, it was shown that the surface structure of BiVO₄ was altered upon photocharging.¹⁰,¹¹ This treatment lead to a suppression of the surface recombination of photogenerated charge carriers, improving the overall photoelectrochemical performance of BiVO₄. In a follow-up work, the pH of the electrolyte was found to have a significant effect on the photocharging enhancement, where an alkaline solution increased the PEC performance more compared to a neutral or slightly acidic electrolyte.¹² Using intensity-modulated photoelectron spectroscopy and a hole scavenger, Liu et al. quantified the enhancement from photocharging in the bulk and at the surface of BiVO₄ in a potassium phosphate buffer.¹³ It was demonstrated that photocharging of BiVO₄ resulted in a significant enhancement in both the bulk charge separation and surface charge transfer efficiencies. Similar photoelectrochemical enhancements have also been recently shown in other metal oxide photoanodes such as WOₓ,¹⁴ CuWO₄,¹⁵ and doped Fe₂O₃,¹⁶,¹⁷ showing that the photocharging treatment has also been recently shown in and surface charge transfer during illumination in a phosphate buffer. A similar copper borate layer was formed during electrolyte interfaces and give new insights into the light-induced heterojunction formation. These results highlight the complex and dynamic nature of metal oxide–electrolyte interfaces and give new insights into the mechanisms for PEC performance enhancement of photocharged BiVO₄ photoanodes. More importantly, this work highlights that the surface adsorption of anionic electrolyte species on metal oxide surfaces cannot be ignored, as it has serious implications on the fundamental understanding and performance analysis of metal oxide photoanodes.

**EXPERIMENTAL SECTION**

**Fabrication of BiVO₄ Thin-Film Photoanodes.** Thin films of BiVO₄ were deposited on fluorine-doped tin oxide (FTO) substrates via spray pyrolysis. The details of the experimental procedure can be found elsewhere.¹⁸ In short, FTO substrates were first coated with ~80 nm of SnO₂, while the substrate temperature was kept at 425 °C, and subsequently coated with 200 nm of BiVO₄ while the substrate was kept at 450 °C. The samples were then annealed in an air-flushed tube furnace for 2 h at 460 °C.

**X-ray Raman Scattering Spectroscopy.** All X-ray Raman scattering spectroscopy data were gathered using the dedicated large solid angle spectrometer at the ID20 beamline of the European Synchrotron Radiation Facility.¹⁹ These experiments were performed in air under atmospheric conditions. A pink beam from four U26 undulators was monochromatized to a 9686 eV elastic energy, first by using a cryogenically cooled Si(111) monochromator and then a Si(311) Channel Cut postmonochromator. The beam was focused using a mirror system in Kirkpatrick–Baez geometry yielding a spot size of approximately 50 × 100 μm² (V × H) at the sample position. Given the experimental setup, the signal coming from 36 spherically bent Si(660) analyzer crystals in the vertical scattering plane was exploited. The overall energy resolution was 0.7 eV, and the mean momentum transfer was 6.2/μm 0.4 Å⁻¹. The reference sample used for this study was a BiVO₄ film prepared as described above and measured without any further treatment at a 0.5° angle relative to the incident beam (penetration depth, 60 nm). Pellets of cellulose and vanadium oxide (V₂O₅ and V₂O₃, Sigma-Aldrich) were also measured at a 0.5° angle. A grazing incidence angle is required to ensure surface-sensitive measurements when a hard X-ray beam is used. Before the XRS measurements, the dark and PC samples were kept in open-circuit conditions in a flow cell with a 0.1 M sodium borate buffer (sodium tetraborate decahydrate, Sigma-Aldrich, 99.5%) in Mill-Q water, while NaOH was added until pH 10 was reached) for 12 h in the dark and under illumination, respectively. The flow cell was further equipped with a glass Ag/AgCl reference electrode (XR300, Radiometer Analytical) and a coated Pt wire as counter electrode both in the dark (dark sample) and under illumination (photocharged sample, 100 mW/cm² Xe lamp with water filter). After 12 h, the electrodes were removed from the electrochemical cell, quickly dried under a flow of nitrogen, and moved to the experimental hutch for the XRS measurements. The preparation procedure was performed very quickly to ensure the XRS measurements could start less than 15 min after the sample was removed from the electrochemical cell. During the XRS measurements, the incident energy was scanned at a fixed analyzer energy of 9.7 keV to create energy losses in the vicinity of the core-electron excitations of interest (L₂,3 of V and K edge of O). The data collected by three pixeled Maxipix detectors²⁰ were integrated over appropriated regions of interest, then averaged over the 36 Si(660) analyzer crystals, and treated with the XRS-tools program package. A background accounting for the valence Compton profile was subtracted as described elsewhere. Twenty-four, finally, a normalization over an area of 40 eV across the edge was applied. Eight energy loss scans per sample were measured at room temperature, each one at a new sample position to avoid beam radiation damage. All XRS measurements were checked for consistency prior to summation to rule out radiation damage of the sample induced by the X-ray beam.

Ab initio XRS simulations at the O K edge were performed with the finite difference method near-edge structure (FDMNES) software package.²¹ The calculated spectra were compared to both photocharged and dark samples. The input parameter files of the calculations are reported in the Supporting Information (SI). The
vanadium L edges were simulated with Crispy using a multiplet analysis approach.

X-ray Photoelectron Spectroscopy. XPS spectra were obtained using a Thermo Scientific K-Alpha apparatus equipped with an Al K-Alpha X-ray source and a Flood Gun for charge compensation of the sample. Parameters used for the measurements were: spot size, 400 μm; pass energy, 50 eV; energy step size, 0.1 eV; dwell time, 50 ms; 10 scans in the vicinity of the Bi 4f, C 1s, Na 1s, O 1s, and V 2p orbital binding energy with alternative scan numbers for B 1s (200 scans) and the valence band (50 scans). Samples were rinsed and dried before measuring.

UV–Vis Spectroscopy. UV–vis transmission measurements were performed on the reference, dark, and the photocharged BiVO₄ samples using a PerkinElmer Lambda 900 UV/Vis/NIR spectrometer. The transmission measurements were performed inside an integration sphere in the transmittance mode (°T). Data were recorded with a 15° tilt in the sample, with respect to the incident light beam to minimize reflection. A scan rate of 250 nm/min and an integration time of 0.2 s were used for the data capture. The absorption coefficient and the Tauc plot were calculated from the transmittance data using the formulas in the S1.

High-Resolution Scanning Electron Microscopy (HR-SEM). HR-SEM images were taken with a Nova NanoSEM at an accelerating voltage of 10 kV.

RESULTS

To gain further insights into the mechanisms of the photoelectrochemical enhancement that arise from the photocharging procedure in BiVO₄, several material properties of BiVO₄ were investigated before and after photocharging. In particular, the influence of placing the photoanodes in solution under open-circuit conditions with and without illumination was examined. A reference BiVO₄ sample (as-deposited) was compared to both a BiVO₄ film that was kept under open-circuit conditions and AM1.5 light illumination (i.e., photocharged) for 12 h and a BiVO₄ film that was kept in open circuit for 12 h in the dark. The samples are referred to as untreated BiVO₄, photocharged BiVO₄ (PC-BiVO₄), and dark BiVO₄ respectively. The samples were studied through several spectroscopic techniques, including UV–vis spectroscopy, XPS, and XRS. Both XPS and XRS give electronic and structural information about the film; however, due to the difference in penetrating depth of the X-rays in the different experiments, XPS gives information about the surface of the films while XRS provides information on the structure up to 60 nm into the bulk of BiVO₄.

X-ray Photoelectron Spectroscopy. XPS measurements were performed on reference, dark, and PC-BiVO₄ films, and the results are shown in Figure 1. The presented spectra are background-subtracted and energy-corrected with the C 1s signal (Figure S1d). Several trends can be observed between the different samples. The Bi 4f peaks are shown in Figure 1a, and a shift was observed from 159.5 eV for the reference sample to 158.7 eV for the dark and photocharged BiVO₄, respectively. This shift is accompanied by slight broadening of the Bi 4f peaks for the dark and the photocharged samples, as shown with the increase in full width at half-maximum in Table S1. A signal from the B 1s spectrum is not present in the reference sample, while it appears very small in the dark and is much more pronounced in the PC-BiVO₄ as seen in Figure 1b. In Figure 1c, the main signal from the oxygen (O 1s) spectra was observed to decrease slightly in binding energy from 530.3 eV for the reference sample to 529.9 and 529.6 eV for the dark and PC-BiVO₄ samples, respectively, while the shoulder peak at 531 eV grows significantly (deconvolution of the O 1s peaks is given in Figure S1). The peak signal from the V 2p spectra is shown in Figure 1c, where a shift to lower binding energies is observed along with a strong signal decrease when looking at the reference, dark, and PC-BiVO₄ films, respectively.

When these results are compared to prior literature, several important similarities can be seen. Favaro et al. found a bismuth phosphate layer forming on the surface of the BiVO₄ films under illumination that slowly disappeared again after the light was turned off. In our current work, the buffer used is not a phosphate but rather a borate electrolyte. The binding energies of Bi to borate and phosphate are not the same, which implies that the peak shift found in our Bi 4f spectrum is not the same as in the work by Favaro. A previous report on Bi₂O₃–Bi₂O₅ glasses reported the Bi 4f binding energies of Bi–O–Bi at 159.85 eV and B–O–Bi at 158.7 eV, which was explained by the presence of boron shifting the Bi signal to lower binding energies. In addition, the O 1s binding energies were reported to be 530.35 eV for Bi₂O₃ and 530.95 eV for B₂O₃. In our work, we find a shoulder in the O 1s spectra at 531.0 eV to increase during photocharging and coincide with the emergence of the B 1s peak at 192.0 eV.

Figure 1. XPS spectra of the reference BiVO₄ and the dark and PC-BiVO₄ samples after 22 h under open-circuit conditions in a borate buffer electrolyte. Spectra of (a) Bi 4f, (b) B 1s, (c) V 2p and O 1s, and (d) the valence band are shown.

When considering the difference between the dark and photocharged samples, it is interesting to note that the electronic features of the dark sample show an intermediate phase between the photocharged and the reference sample. Although the dark sample has no clear B 1s signal, it still has a partial shoulder in the O 1s spectrum, and it is likely that this sample instead has a surface coverage of bismuth hydroxide as previously reported. Since the binding energies for Bi–O–B and Bi–O–H are almost identical (the electronegativity values
of H and B are 2.2 and 2.0, respectively), the distinction is difficult to make without analyzing the B 1s signal as well.

The valence band (VB) of the reference, dark, and PC-BiVO$_4$ electrodes was also examined, and is shown in Figure 1d. It can be seen from this figure that similar to the previously observed shifts in the binding energy of Bi, O and V, there is also a shift in the valence band energy toward lower binding energies when looking at the reference, dark, and PC-BiVO$_4$ samples, respectively.

A broadening to lower binding energy of the valence band spectra of the dark and PC-BiVO$_4$ is also visible, due to the convolution of the VB spectra of bismuth hydroxide/bismuth borate and bismuth vanadate, respectively. These results indicate that the bismuth borate layer formed on the surface has a valence band closer to the Fermi level of the composite system. The exact composition of the bismuth borate surface layer is unknown, but from prior work on bismuth borate glasses, we can estimate the band gap of the bismuth borate layer to be equal to or larger than that of BiVO$_4$.20,26

The unidirectional peak shifts in the Bi 4f, V 2p, O 1s, and VB XPS spectra to lower binding energies are in part an electronic effect. Band bending caused by the equilibration of the Fermi level of BiVO$_4$ and the chemisorbed anionic surface layer shifts the XPS spectra. Similar XPS peak shifts were observed by Hermans et al.27 where different metal oxide surface layers were deposited on BiVO$_4$, and the peak shifts were attributed to a change in Fermi level position because of the surface layer-induced band bending. NiO and CoO$_2$ surface layers lead to an upward band bending, whereas indium-doped tin oxide induced a downward band bending in BiVO$_4$ due to the differences in their respective work functions compared to that of BiVO$_4$. The core-level XPS spectra shifted to lower binding energies with the deposition of NiO and CoO$_2$ overlayers, similar to the shifts seen with dark and PC-BiVO$_4$ in this study. Note that band bending-induced shifts should be equal in magnitude for different core levels. Table S2 shows that the shifts for V and Bi are larger than those for O, meaning that the V and Bi shifts also have a chemical component to them, assigned above as a reduction in V oxidation state and the appearance of the Bi borate surface layer.

The formation of the bismuth borate layer at the surface forms a heterojunction with the BiVO$_4$ which induces an upward band bending and reduces photogenerated charge recombination at the semiconductor—liquid junction. The cathodic Fermi level shift that was observed with the open-circuit potential measurements for the dark and photocharged samples, as shown in Figure S2, is another evidence of the band bending observed through the XPS shifts.

**Ultraviolet–Visible Spectroscopy.** UV–vis spectroscopy was performed before and after the photocharging process to determine if there were any optical changes in the BiVO$_4$ films during the treatment that may arise from the formation of the bismuth borate surface layer. In Figure 2a, the spectra of a dark (green) and photocharged (yellow) sample are shown together with their corresponding spectra before treatment. A small increase in absorption is found within the band gap of BiVO$_4$ for the photocharged sample, while the dark sample does not show this increase in absorption. Just outside the band gap energy, between 475 and 700 nm, the photocharged sample shows a very distinct absorption feature.

The absorption increase inside the band gap could explain part of the improved OER activity of the PC-BiVO$_4$ sample but cannot account for the observed 3-fold increase in the incident photon-to-current conversion efficiency.11 To determine whether the choice of buffer anion has any effect on this absorption feature, photocharging was performed in a phosphate buffer at pH 10. This treatment revealed a very similar improvement within the absorption spectra after photocharging (Figure S3a). When subtracting the spectrum of the before-PC from the after-PC spectrum (Figure 2b), a feature emerges that resembles either a surface plasmon resonance mode with a peak in absorption around 520 nm or a defect-related absorption in PC-BiVO$_4$. The dark sample only has a minor increase in this region, but still shows a feature with a peak centered around 520 nm. Plasmonic features of vanadium oxide are only found in the infrared region,28 and those for metallic vanadium are found in the UV region,29 whereas metallic bismuth nanoparticles in an oxide medium can give rise to plasmonic features around 500 nm.20,30

However, the Bi 4f XPS spectra do not show any indication of the presence of metallic bismuth in the PC-BiVO$_4$. Therefore, we tentatively assign this feature to defect-related light absorption in PC-BiVO$_4$. In fact, such above band gap optical features have been observed with some metal oxides31,32 and have often been attributed to defect-related light absorption, induced by surface oxygen vacancies. Therefore, the anion adsorption on the BiVO$_4$ surface upon photocharging could have introduced surface oxygen vacancies through surface restructuring. A high-resolution scanning electron microscopy (HR-SEM) image of PC-BiVO$_4$ (Figure 2c) shows severe roughening of the surface on the nanoscale, compared to the
dark and reference samples (Figures 2d and S3c, respectively). This surface roughening could be a result of the surface restructuring to accommodate the buffer anion adsorption.

**X-ray Raman Scattering.** To gain further insight into the structural and electronic changes induced by the photocharging treatment, the vanadium L_2 and L_3 edge and the oxygen K edge were probed using X-ray Raman scattering spectroscopy in near in situ conditions. X-ray absorption spectroscopy uses soft X-rays to probe light elements (<1 keV); however, these X-rays require ultra-high-vacuum conditions and are therefore less suitable for in situ studies. Instead, XRS allows the use of hard X-rays to probe elements with core-electron excitation energies in the soft X-ray regime, i.e., lower than 1 keV. The use of hard X-rays leads to a bulk-sensitive approach and can offer the possibility of working under operando conditions. In this work, we were able to study the BiVO_4 structure at room temperature and pressure and measure spectra immediately after the photocharging treatment was performed. Real operando conditions would greatly complicate the analysis of the O K edge spectrum since the electrolyte also contains oxygen, instead this near in situ approach was adopted. A grazing incidence angle was maintained to avoid contributions from the oxygen-containing FTO substrate and to increase the footprint of the X-ray beam on the sample. The vanadium L_1 and L_2 edges and oxygen K edge can be probed within the same measurement since their absorption energies are very close. The electronic structure of BiVO_4 has a C_2 symmetry, leading to triplet splitting of the V 3d orbitals; however, this part of the spectrum is noisier than the V L_3 edge because the core hole lifetime at the L_2 edge is shorter resulting in a broader spectrum. All excited-state energies that are visible in Figure 3 are given in Table 1 with their corresponding orbital transitions. Overall, the XRS spectra shows good agreement with soft X-ray absorption near-edge structure (XANES) spectra of BiVO_4 in the literature.

The oxygen K excitations extend from 528 eV upward and consist of transitions from the occupied O 1s orbital close to the core of the oxygen atom to the unoccupied O 2p states. A peak at 531 eV and its shoulder at 530 eV show the O 2p–V 3d hybridization and thus represent the same orbitals as the V L_2 and L_1 edge spectrum. Therefore, these regions are observed in the oxygen K edge region of a reference, dark, and PC-BiVO_4 sample. The changing ratio of the O K edge peaks reveals a filling with electrons of the pre-edge peak (O 2p–V 3d |ε)|t_2g) for the dark sample. The vanadium L edge excitation results in a transition to the first available vanadium d orbital and the oxygen K edge excitation transitions to the first unoccupied oxygen p orbital.

The XRS spectrum of the reference thin-film BiVO_4 sample (dashed blue line in Figure 3) is discussed first. Four main peaks with shoulders to the left of the first three peaks are easily discernible. The first main peak between 515 and 520 eV corresponds to the V L_1 edge: the excitation from V 2p_1/2 to conduction band V 3d states; the second main peak from 521 to 528 eV is the V L_2 edge: the excitation from 2p_3/2 to the conduction band V 3d states. The L_3 region consists of a main peak at 518 eV and a shoulder at 516 eV, which are the t_2g (main peak) and e_g (left shoulder) states of the VO_4 structure within the BiVO_4 lattice. The V 3d orbitals are hybridized with the O 2p orbital. The L_2 edge is excited to the same (hybridized) V 3d t_2g and e_g states; however, this part of the spectrum is noisier than the V L_3 edge because the core hole lifetime at the L_3 edge is shorter resulting in a broader spectrum. All excited-state energies that are visible in Figure 3 are given in Table 1 with their corresponding orbital transitions.

<table>
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<th>probed edge</th>
<th>energy (eV)</th>
<th>electronic transition</th>
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<tr>
<td>V L_1</td>
<td>516</td>
<td>e_g V 3d–O 2p (t_2g, e_g)</td>
</tr>
<tr>
<td>V L_2</td>
<td>523</td>
<td>t_2g V 3d–O 2p (d_2g, d_2u, d_2u)</td>
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<tr>
<td>V L_3</td>
<td>530</td>
<td>e_g V 3d–O 2p</td>
</tr>
<tr>
<td>O K</td>
<td>532</td>
<td>t_2g V 3d–O 2p</td>
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<td></td>
<td>534</td>
<td>σ^* Bi 6p–O 2p</td>
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<td></td>
<td>540</td>
<td>σ^* from V 4s and Bi 6s with O 2p</td>
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**Figure 3.** Normalized XRS spectra of the vanadium L_2, L_3, and the oxygen K edge region of a reference, dark, and PC-BiVO_4 sample. The changing ratio of the O K edge peaks reveals a filling with electrons of the pre-edge peak (O 2p–V 3d |ε)|t_2g) for the dark sample.

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Chem. Mater. XXX, XXX, XXX--XXX
deposited BiVO₄ is highly nanostructured and hence has a high only the fi

Figure 4. (a) XRS spectra of the vanadium oxides (V₂O₅ and V₂O₃) are presented together with the reference, dark and PC-BiVO₄ to show the effect of changing V oxidation state on the peak position in the V L₂ and L₃ edge spectra. (b) The O K edge spectra of the dark and PC sample are overlaid with ab initio simulations including the semiempirical dilatorb and screening parameters.

orbitals. This is not easily discernible from the measured spectrum because of the lower resolution of XRS compared to standard soft X-ray XANES. However, it is important to realize that the broad peaks observed are composed of overlapping contributions of several orbitals.

XRS spectra of V⁴⁺ and V⁵⁺ reference samples were collected to help interpret the oxidation state of V in BiVO₄. These reference spectra were plotted together with those of reference, dark, and photocharged BiVO₄ and are presented in Figure 4a. As is evident from the figure, the peaks of the V⁵⁺ reference sample (dark blue) are shifted to lower binding energies compared to the peaks of the V⁴⁺ sample (purple). This is in very good agreement with the other studies in the literature. Another interesting aspect is that the peaks in the V L edge spectra for the reference, dark, and PC-BiVO₄ are in between the V⁴⁺ and V⁵⁺ L edge reference spectra. From this, it can be concluded that the spray-deposited BiVO₄ has a mix of V⁴⁺ and V⁵⁺ oxidation states. In an ideal BiVO₄ lattice, the vanadium species should have a 5+ oxidation state. However, it is very common to have intrinsic defects in the structure, in the form of oxygen vacancies. These oxygen vacancies are responsible for the n-type character of monoclinic BiVO₄. Due to these oxygen vacancies, to maintain charge neutrality, some vanadium species in the BiVO₄ lattice could exist in the 4+ oxidation state. Rossell et al. quantified the vanadium oxidation state in monoclinic BiVO₄ using energy loss spectroscopy and suggested that the surface vanadium ions predominantly exist in a ~4+ oxidation state, due to the presence of a significant amount of oxygen vacancies.

To better understand these results, it is important to consider the penetration depth of the performed XRS measurements. Due to the grazing incidence angle of 0.5°, only the first 60 nm are probed. Additionally, the spray-deposited BiVO₄ is highly nanostructured and hence has a high surface-to-volume ratio. Therefore, the obtained vanadium L edge spectra for the reference, dark, and photocharged samples could be an average of the surface and bulk oxidation state of vanadium that fall between the 4+ and 5+ oxidation states. These results are in alignment with the XRD patterns that show a strong resemblance between the reference and photocharged samples, both having monoclinic scheelite BiVO₄ features (Figure S4). The reference, dark, and photocharged BiVO₄ have similar vanadium L edge peak positions. However, the dark and PC-BiVO₄ show a slightly different ratio in intensity between the V L₃ and L₂ edges compared to the reference spectra. A multiplet analysis was performed to predict the shape of the V L edge spectra for a vanadium species in its V⁴⁺ and V⁵⁺ oxidation state, in a hypothetical bismuth vanadium oxide compound. These results are shown in Figure S5 and suggest that there could be a decrease in the oxidation state of vanadium with an increase in the L₃/L₂ peak ratio. The V L₃/L₂ peak ratio is indeed higher for the dark and PC-BiVO₄ compared to the reference (Table S3) and would suggest a decrease in the oxidation state of vanadium, possibly from the creation of additional oxygen vacancies at the surface. This would be in agreement with the above band gap absorption feature seen in the absorption spectra of the PC-BiVO₄ and with the shift in the V 2p XPS spectrum. However, the low resolution of the XRS technique coupled with the surface and bulk averaging of the XRS technique makes this comparison difficult. Screening of V 2p XPS spectra by the surface-adsorbed layer also makes the comparison of the V 2p XPS spectra difficult. Additional experiments will be needed to study and quantify the vanadium oxidation state change in the dark and the photocharged sample, which is out of the scope of this work.

A disappearance of the O 2p–Bi 6p peak at 534 eV was observed for both the PC sample and the dark sample. As mentioned previously, the Bi–O hybridization is not very strong; therefore, a small change in the electronic structure can make the Bi 6p signal less visible, which appears to be the case for the dark sample. Bismuth borate withdraws bismuth from BiVO₄, which leads to the reduction of the O 2p–Bi 6p signal in the XRS spectrum of the photocharged BiVO₄. The broadening of the mixed metal sp–O 2p peak implies the existence of multiple orbitals that partly overlap in energy. This can be caused by the presence of multiple V oxidation states that all have molecular orbitals of slightly different energy.

The main difference between the dark and PC-BiVO₄ XRS spectra is the filling with electrons of the V 3d states of the dark sample, as observed from a difference in peak height ratio between the pre-edge peak (V 3d–O 2p) and the main peak (mixed metal sp–O 2p) in the O K edge spectrum. This lowering of the pre-edge peak implies a filling of the d states, resulting in a higher concentration of electrons for the dark sample compared to the reference and photocharged samples. The reason for this difference is not immediately obvious, so to further elucidate and quantify the influence of the photocharging treatment on the electronic structure of BiVO₄, ab initio simulations at the O K edge were performed with the FDMNES program package. The calculated spectra were
compared to the experimentally obtained XRS spectra (the input parameter files of the calculations are shown in the SI).

To simulate the peak height ratios observed in the experimental XRS spectra, two semi-empirical parameters, the dilator $b$ and screening parameters, were used in the calculations. The dilator $b$ and screening parameters provide the ability to tune the height of the pre-edge peaks and their position with respect to the main edge. Moreover, the dilator $b$ parameter provides the ability to consider the degree of ionicity of oxygen in the lattice structure by modifying the valence orbitals. Modifying this parameter means either dilating or contracting the valence orbitals, which is a necessary procedure when modeling anions with this package since the default is fully covalent, not considering the ionic character of oxygen.41 Anions have a more negative charge and are larger than their covalent radius because of the extra electrons that the anions take from the cations. The effect of changing the dilator parameter is shown in Figure S6.

The screening parameter is used to simulate a not fully screened core hole in the absorbing atom, meaning that part of the electron charge in the conduction band is missing. When the total excited electron is present in the conduction band, no charge is missing and the core hole is considered fully screened. The screening parameter generally points to a correlation effect caused by the presence of the excited 3d electrons that hinder the screening process. In this respect, the screening value is an indication of the filling with electrons of the conduction band. However, oxygen electrons can behave unexpectedly to the removal of electrons, and it is therefore not always possible to predict the pattern in the O K edge spectra as a function of electron depletion. Instead, the screening parameter can help making the trends of the spectra quantifiable. The effect of changing the screening parameter is shown in Figure S7.

If the effects of the dilator and the screening value are now combined, it is possible to effectively simulate the XRS spectra. The best fitting simulations are shown in Figures 4 and S8.

Figure 5. Effect of photocharging on the band gap region and the Fermi level of BiVO$_4$. (a) Hydroxide (dark sample) and bismuth borate (PC sample) surface layers have a valence band closer to the Fermi level, introducing band bending at the surface. The band bending directs electrons toward the bulk of BiVO$_4$, leading to a reduced electron concentration in the space charge region for PC-BiVO$_4$. Note that the bulk band gap size is not altered by the PC treatment (Figure S10). (b) The effect of photocharging on a BiVO$_4$ photoanode in contact with an electrolyte under illumination. The additional band bending improves the charge separation, leading to the unrivaled PEC properties of PC-BiVO$_4$. The reference spectrum (Figure S8) was fitted with a dilatorb value of 0.1 and no screening potential. The dark sample is fitted with a screening value of 0.1 and the dilator set to 0.1. The photocharged sample, on the other hand, is fitted with a screening parameter of 0.2 and a dilatorb value of 0.1. The default value for the screening parameter is 0 in the FDMNES software, so the lack of a defined screening value in the reference sample should be understood as full screening. The trend in the screening between the different samples is therefore: reference > dark > photocharged BiVO$_4$.

The difference in screening value between the dark and PC spectra can be explained by the photocharged sample having less electrons in the conduction band than the dark sample in the area measured by XRS, which also explains the pre-edge filling of the dark sample observed in Figure 3. The screening value of 0.2 for PC-BiVO$_4$ is significantly higher with respect to the value of 0 that was used for the reference sample, showing strong structural changes in BiVO$_4$ as a result of the photocharging treatment. A higher screening value also indicates a shift to a lower Fermi level since less electrons are present in the conduction band. Less electrons for the photocharged sample might seem counterintuitive, but in fact, it is a consequence of improved band bending induced by the heterojunction between BiVO$_4$ and the surface-formed bismuth borate layer. The fact that electrons are driven away from the surface by band bending is responsible for the strong suppression of surface recombination induced by the photocharging treatment. The decrease in Fermi level is also introduced in the simulations. The dark sample also has less electrons compared to the reference sample and a lower Fermi level, but the changes are smaller compared to the photocharged sample.
The XPS analysis confirmed the formation of a bismuth borate surface layer on BiVO₄ upon photocharging. The shifts of the core-level XPS spectra, to lower binding energies upon photocharging, suggested that this borate surface layer induced an upward band bending within BiVO₄ (Figure 5a). Similar conclusions could be drawn in the case of the dark samples. After 18 h under open-circuit conditions in the dark, the dark sample has an OH coverage that initially improves the photoelectrochemical performance of the sample (Figure S9). This improvement is, however, smaller than the PEC improvement of the PC samples and is not maintained over time because the OH species are removed from the surface during water oxidation. Both the dark and photocharged samples demonstrated a higher open-circuit potential in the dark than the reference sample (Figure S2), resulting in a Fermi level closer to the conduction band in the bulk, as depicted in Figure 5a. To determine whether the bismuth borate and OH surface layers had any effect on the bulk structure of BiVO₄, both UV−vis and XRS measurements were performed. The UV−vis spectra revealed a change in absorption after photocharging, with the formation of an above band gap absorption feature. This feature was attributed to a defect-related absorption, possibly from the creation of surface oxygen vacancies.

To gain a deeper understanding of the electronic effect of the bismuth borate layer on BiVO₄, XRS measurements were performed. These results showed that the hybridized Bi 6p−O 2p orbital disappeared, which corresponds well to the formation of a bismuth borate surface layer. In addition, the ab initio simulations of the O K edge spectra revealed a decrease in the Fermi level of the PC-BiVO₄. This can be explained by band bending induced by the surface borate layer. Bismuth borate has a larger band gap than BiVO₄ and according to the valence band spectra (Figure 1d), its valence band lies closer to the Fermi level than the valence band of BiVO₄. This means that the heterojunction of BiVO₄ and bismuth borate will create strong band bending and a significant space charge region (SCR) of several tens of nanometers (Figure 5a).32,48 The SCR coincides with the region that is probed by XRS. Since the band bending forces electrons toward the back contact, the SCR will contain fewer electrons than in the case of a flat band situation. The monolayer of OH on the surface of the dark BiVO₄ sample has a similar band bending effect that directs the electrons toward the back contact, away from the surface.

The XRS results from this work suggest that there is a severe alteration in the surface electronic structure when BiVO₄ comes in contact with an electrolyte, even without illumination. This is also supported by the changes visible in the data obtained from XPS and HR-SEM. The initiator of this surface restructuring could be the surface adsorption of electrolyte anionic species, borate in the case of the PC-BiVO₄ and hydroxide in the case of dark BiVO₄. The heterojunctions formed as a result of this surface adsorption improve the charge separation close to the surface and thus suppress surface recombination. Since other metal oxides13,14,16 were also shown to photocharge like BiVO₄, these findings could be generalized.

Additionally, this time-dependent surface layer formation shows that the metal oxide/electrolyte interface is very dynamic. Reversibility of the photocharging effect10 in the dark could be explained by the desorption of this buffer anion surface layer under dark conditions, which was also shown by Favaro et al.17 The dynamic nature of the metal oxide/electrolyte interface makes it difficult for the photoanode material to be stable for long-term operation. The constant switching between the dark and light conditions, as in a practical case where intermittent sunlight drives the reaction, would imply constant surface restructuring of the photoanode material. Some material from the surface could be lost in each of these restructuring steps, in addition to other corrosion mechanisms occurring at the surface of a photoanode material.

It is important to emphasize that this surface layer formation, in the dark and under illumination, from the electrolyte anionic species has been “ever-present” in metal oxide photoanodes. This work highlights that the choice of electrolyte/buffer solutions needs to be considered when making comparisons of PEC performance of different systems with the same metal oxide semiconductor. The surface layer formed would be different with different electrolytes and hence the resultant heterojunction would change as well. However, the importance or the effect of the electrolyte has been largely unnoted in the PEC research field when analyzing material surfaces after photoelectrochemical measurements. This current study is a strong indicator that the effect of surface adsorption of electrolyte anionic species can have serious implications on PEC measurements and should be given due regard for future works in the field.

The photocharging treatment of BiVO₄ was studied using a sequence of XPS, UV−vis, and XRS techniques. The XPS studies revealed the formation of a surface borate layer on the BiVO₄ surface, upon illumination in open-circuit conditions. The borate anion from the electrolyte covalently bonded with the bismuth ions in the BiVO₄, resulting in a BiVO₄/bismuth borate heterojunction near the surface. This heterojunction resulted in improved band bending near the surface, improving the charge separation and suppressing the surface recombination of charge carriers. The improved band bending, as a result of the heterojunction, explains the enhancement in the PEC performance of photocharged BiVO₄. In a similar manner, a BiVO₄ sample kept under open-circuit conditions in the dark formed an OH layer at the surface, leading to a relatively smaller degree of band bending and a short-lived PEC performance enhancement.

The UV−vis studies showed the formation of a new absorption feature, outside the band gap of BiVO₄, upon photocharging. This feature was attributed to a defect-related absorption, resulting from the surface restructuring during photocharging. This surface restructuring during photocharging was confirmed using HR-SEM images. A combination of XRS studies and ab initio simulations on the oxygen K edge spectra revealed a decrease in the electron occupancy in the space charge region of the dark and PC-BiVO₄ samples, confirming the improvement in band bending after the dark and photocharging treatment. Additionally, the XPS, UV−vis, and XRS measurements indicated a decrease in the oxidation state of the surface vanadium species due to the anion adsorption. Further experiments are required to quantify this change.

A strong agreement was found between the XRS spectra obtained in this work and soft X-ray XANES spectra from others, indicating that XRS is a very powerful tool to study
semiconductors in (near) in situ conditions with a larger probing depth than allowed by soft X-ray techniques. The dynamic nature of the metal oxide/electrolyte interface will have strong implications on the long-term stability of metal oxide photoanodes. The effect of surface adsorption of electrolyte anionic species on the surface structure of metal oxide photoelectrodes is often overlooked within the PEC research field. Our results show that this time-dependent surface adsorption of electrolyte anionic species on the metal oxide photoanode surface plays an important role in defining the electronic and catalytic properties of a photoanode. Anionic adsorption was shown to form a heterojunction at the surface, which improved charge separation and suppressed surface recombination. The effect of the electrolyte on the metal oxide photoanode surface and the time scale of the surface adsorption of these anions cannot be ignored, and hence should be taken into consideration while performing analyses and gaining mechanistic understanding of reactions on metal oxide photoanode surfaces.

■ ASSOCIATED CONTENT

Supporting Information

The Supporting Information is available free of charge on the ACS Publications website at DOI: 10.1021/acs.chemmate.9b02121.

Additional XPS spectra and UV−vis spectra, HR-SEM image, XRD pattern, XRS simulations, and FDMNES input file; PEC performance data; and band gap calculation (PDF)

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Notes
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**NOTE ADDED AFTER ASAP PUBLICATION**

Due to a production error, this paper was published on the Web on August 14, 2019, with the first co-author name misspelled. The corrected version was reposted on August 16, 2019.